



22W

PATENT  
Customer No. 22,852  
Attorney Docket No. 04329.3299

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of: )  
)  
Tsutomu Sato et al. ) Group Art Unit: 2815  
)  
Application No.: 10/820,182 ) Examiner: WILSON, Allan R.  
)  
Filed: April 8, 2004 )  
) Confirmation No.: 7391  
For: SEMICONDUCTOR DEVICE AND )  
METHOD OF MANUFACTURING )  
THE SAME )

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**RESPONSE TO RESTRICTION REQUIREMENT**

In a restriction requirement mailed February 3, 2006, the period for response to which extends through May 3, 2006, the Examiner required restriction under 35 U.S.C. § 121 between Group I, claims 1-15, characterized by the Examiner as being drawn to a semiconductor device; and Group II, claims 16-20, characterized by the Examiner as being drawn to a method of making a semiconductor device. Applicants elect to prosecute Group I, claims 1-15, without traverse.


Please grant any extensions of time required to enter this response and charge any additional required fees to our deposit account 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,  
GARRETT & DUNNER, L.L.P.



Dated: March 2, 2006 .

By:  #27,432  
Richard V. Burgujian  
Reg. No. 31,744